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BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 8481

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SERIAL NUMB 10/635,621		FILING DATE 08/06/2003 RULE	(CLASS 438	GRO	UP ART 2812	UNIT	D	ATTORNEY OCKET NO. SM02-0971	
APPLICANTS										
Hsi-Kuei Cheng, Hsin-Chu, TAIWAN;										
Hung-Ju Chien, Hsin-Chu, TAIWAN; Hsun-Chang Chan, Hsin-Chu, TAIWAN;Chu-Chang Chen, Hsin-Chu, TAIWAN; Ying-Lang Wang, Hsin-Chu, TAIWAN; Chin-Hao Su, Hsin-Chu, TAIWAN; Hsien-Ping Feng, Taipei, TAIWAN; Shih-Tzung Chang, Taichung, TAIWAN;										
** CONTINUING DATA **********************************										
** FOREIGN APPLICATIONS ************************************										
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met Verified and Acknowledged		Allowance \	er tials	COUNTRY TAIWAN		WING 5	CLAI 21		CLAIMS 4	
ADDRESS 43859 TAIWAN SEMICONDUCTOR MANUFACTURING CO., LTD. C/O SLATER & MATSIL, L.L.P. 17950 PRESTON ROAD, SUITE 1000 DALLAS , TX 75252										
TITLE Method for reducing defects in post passivation interconnect process										
							All Fees			
							1.16 Fees (Filing)			
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		Page 2 of 2
RECEIVED	No;or following:	1.18 Fees (Issue)
924		Other
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